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Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hiroyuki TAKAHASHI, et al.) Re: Information Disclosure
Serial No.: 10/585,673) Statement
Filed: July 6, 2006) Group: not yet assigned
For: "PARTICLE DETECTION DEVICE AND) Examiner: Unknown
PARTICLE DETECTION METHOD") Our Ref: B-6037PCT 623562-9
Date: December 19, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria VA, 22313-1450

Sir:

In accordance with the Applicants' duty to disclose information which may be material to the examination of this application, the undersigned respectfully requests that the Examiner consider on the merits the documents listed on the enclosed Form PTO-1449 (modified) before issuing the first Office Action on the merits. Copies of the foreign documents listed are enclosed herewith. Copies of the U.S. documents listed on the enclosed Form PTO-1449 (modified) are not enclosed in accordance with 37 C.F.R. § 1.98(a) (2) (ii).

The foreign documents listed are those cited in an International Search Report for the corresponding PCT Application. A copy of the International Search Report is enclosed herewith.

The filing of this Information Disclosure Statement (IDS) shall not be construed as a representation that a search has been made (37 C.F.R. 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability, or that no other material information exists.

The Applicants believe that this IDS is being submitted before the issuance of a first Office Action on the merits and before the issuance of a Final Rejection or Notice of Allowance. Therefore, no official fees should be due; and this IDS should be considered on the merits. If this IDS is being submitted after the issuance of the first Office Action on the merits and before the issuance of a Final Rejection or Notice of Allowance, please

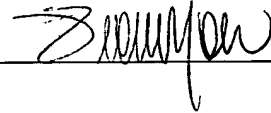
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contact the undersigned to authorize a payment of \$180.00 (or any other required amount), which is the fee set forth in 37 C.F.R. § 1.97(c), if the Examiner believes that such a fee is due in order for this IDS to be considered on the merits.


The filing of this Information Disclosure Statement shall not be construed as an admission against interest in any manner. (Notice of January 9, 1992, 1135 O.G. 13-25, at 25.)

The person making this statement is the practitioner who signs below on the basis of information supplied by an individual associated with the filing and prosecution of this application (37 C.F.R. § 1.56(c)) and on the basis of information in the practitioner's file.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first-class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450", on December 19, 2006 by Veronica Yoon



Respectfully submitted,

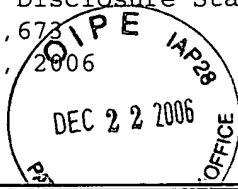


Robert Popa
Attorney for Applicant
Reg. No. 43,010

LADAS & PARRY
5670 Wilshire Boulevard
Suite 2100
Los Angeles, CA 90036
(323) 934-2300

Enclosures: Form PTO-1449 (modified) (1 page)
Copy of each foreign document listed

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Form PTO-1449 (Modified) Page 1 of 1	ATTY DOCKET NO. B-6037PCT 623562-9	U.S. SERIAL NO. 10/585,673
LIST OF PATENTS AND PUBLICATIONS STATEMENT	APPLICANTS Hiroyuki TAKAHASHI, et al.	
	FILING DATE July 6, 2006	GROUP Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUB- CLASS	FILING DATE or 102(e) DATE IF APPROPRIATE
	6,933,506 B2	8/2005	Takahashi	250	385.1	
	6,703,619	3/2004	Takahashi	250	385.1	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Takahashi, H., "Chuseishi Sanran Jikken no Tameno Micro Strip gas Hirei Keisukan", Ionizing Raidation, ISSN0285-3604, Vol.29, No.4, pages 179 to 187 (October 2003)
	Kai, A., "Cathode Denkyoku Pattern o Kufu Shita Micro Strip Gas Hirei Keisukan no Kaihatsu", Extended abstracts; the Japan Society of Applied Physics, Vol.64, No.1, page 71 (August 2003)

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.